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| U.S. PATENT DOCUMENTS   |       |   |          |   |       |   |                               |
| Examiner's<br>Initials  | Class | Document Number   | Date     | Name                                      | Class | Subclass  | Filing Date<br>if Appropriate |
| gag   | AA    | 4,377,437 /   | 03/22/83 | Taylor et al.                             |       |   |                               |
|   | AB    | 5,853,925 /   | 12/29/98 | Huh                                       |       |   |                               |
|   | AC    | 6,042,996 /   | 03/28/00 | Lin et al.                                |       |   |                               |
| gag   | AD    | 6,232,229 B1 /  | 05/15/01 | Reinberg                                  |       |   |                               |
|   | AE    |   |          |   |       |   |                               |
|   | AF    |   |          |   |       |   |                               |
|   | AG    |   |          |   |       |   |                               |
|   | AH    |   |          |   |       |   |                               |
|   | AI    |   |          |   |       |   |                               |
| FOREIGN PATENT DOCUMENTS  |       |   |          |   |       |   |                               |
|   |       | Document Number   | Date     | Country                                   | Class | Subclass  | Translation<br>Yes No         |
| gag   | AJ    | 59-53842 /  | 03/28/84 | Japan (Seichi et al.)                     |       |   |                               |
|   | AK    | 61-177720 /   | 08/09/86 | Japan (Hiroaki et al.)                    |       |   |                               |
|   | AL    |   |          |   |       |   |                               |
| OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)   |       |   |          |   |       |   |                               |
| gag   | AM    | Adesida et al., <i>The range of light ions by polymeric resists</i> , J. APPL. PHYS. 56 (6), pp. 1801-1807 /    |          |   |       |   |                               |
|   |       | (September 15, 1984).   |          |   |       |   |                               |
| gag   | AN    | Meingailis et al., <i>A review of ion projection lithography</i> , J. Vac. Sci. Technol. B 16(3), pp. 927-956 / |          |   |       |   |                               |
|   |       | (May/June 1998).  |          |   |       |   |                               |
|   | AO    |   |          |   |       |   |                               |
| EXAMINER  |       | DATE CONSIDERED   |          |   |       |   |                               |
| George Goudreau   |       | 12-04'  |          |   |       |   |                               |
| *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. |       |   |          |   |       |   |                               |